IN THE UNITED STATES PAPENT AND TRADEMARK OFFICE

NOV 1 5 1999

IN RE APPLICATION OF: ADAMS

SERIAL NO.: 09/049,314

FILED: 3/27/98

T: 3652 EXAMINER: Bucci, D.

TITLE: SUBSTRATE PROCESSING APPARATUS WITH SMALL BATCH LOAD

LOCK

ATTORNEY DOCKET NO.: 390P007204-US(PAR)

The Commissioner of Patents and Trademarks Washington, D.C. 20231

## AMENDMENT

Sir:

This is in response to the Office Action mailed 8/11/99 (Paper no. 5) in regard to the above-identified patent application. Please amend the application as follows:

## IN THE CLAIMS:

## Please amend the Claims as indicated below:

- 1. (Amended) A substrate load lock comprising:
- a frame forming at least three chambers; and

a substrate support movably mounted to the frame to move relative to the frame from an initial position to a final position, the substrate support having at least two separate support areas, a first one of the support 11/23/1999 TWILLIAE 0000000areas being movable between a first one of the chambers 36.30  $E_{\overline{a}}$  and a second one of the chambers, and [,] a second one

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